

Future opportunities for emission channeling lattice location experiments using position-sensitive detectors and radioisotopes produced at HIE-ISOLDE

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-WHY EMISSION CHANNELING?

Dopant / impurity properties depend on lattice sites

Impurity sites depend on many parameters:

Chemical nature

Point defects

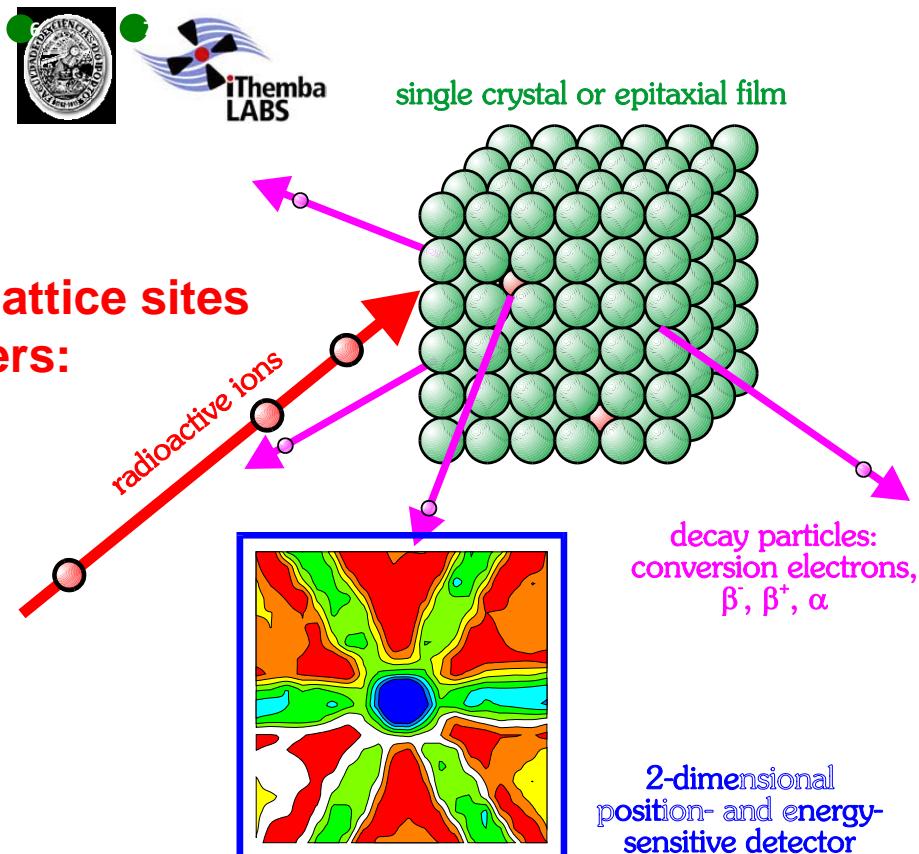
Ionic radius

Temperature

Emission channeling precision $\sim 0.1 \text{ \AA}$

IS453 EC-SLI experiment

Emission Channeling with Short-Lived Isotopes



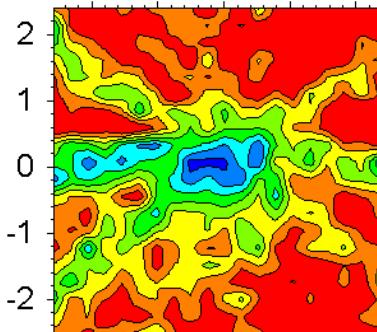
EMISSION CHANNELING

MAJOR FIELD OF APPLICATIONS:

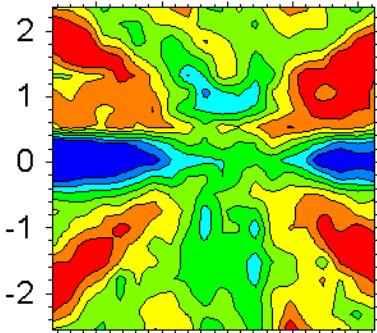
Lattice location of dopants and impurities in semiconductors and oxides

^{59}Fe (β^-) in Si

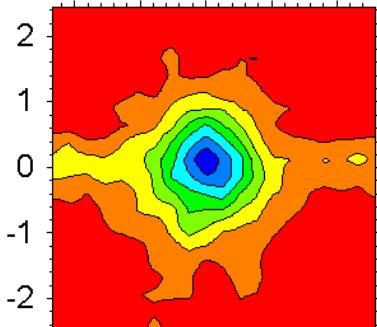
<110> axis view



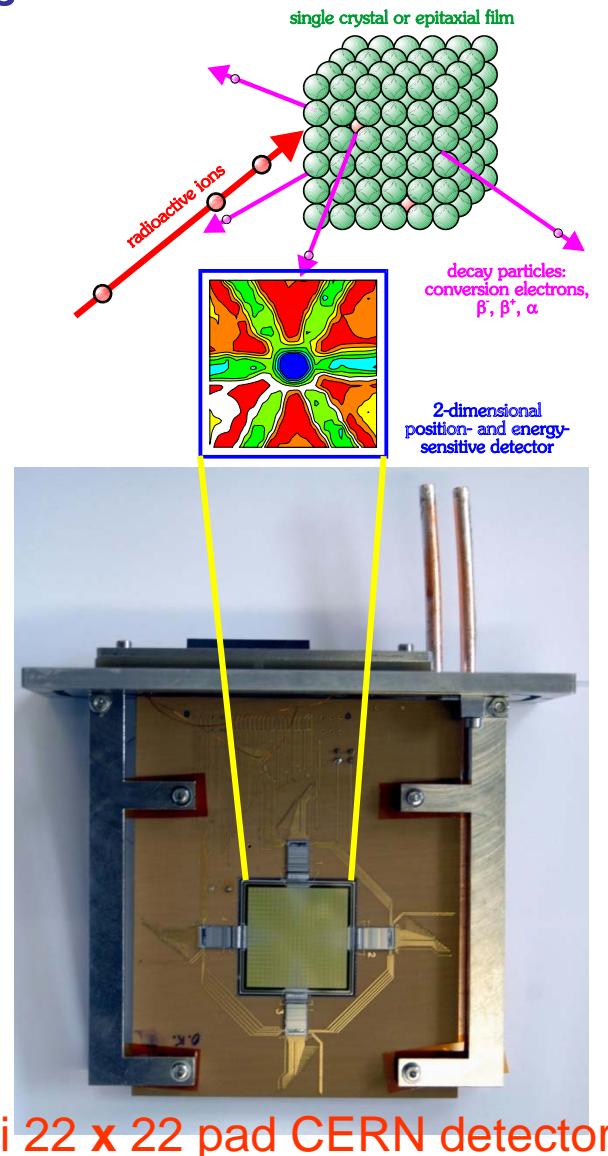
as implanted
Fe @ Si sites
0.5 Å
displaced



$T_A = 300\text{ }^\circ\text{C}$
Fe @
tetrahedral
interstitial



$T_A = 800\text{ }^\circ\text{C}$
Fe @ Si sites
ideal sites



Si 22 x 22 pad CERN detector

EC-SLI uses various types of position-sensitive detectors:

- Si pad detectors (developed at CERN for Compton camera project) for β^- and conversion electrons
- CCD for low-energy (< 40 keV) conversion electrons
- Resistive charge division for α particles
- FUTURE:
CERN MediPix and TimePix
512 x 512 pixel detectors

New perspectives at HIE-ISOLDE

- EC-SLI has been used for a variety of radioisotopes, but not all elements are available at ISOLDE
- Availability of a number of (new) radioactive probe isotopes is expected for HIE-ISOLDE
- Beam development for some others is encouraged!

